

Instrumentation Development for a Novel Local Electric and Magnetic Field Fluctuation Diagnostic

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On behalf of:

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Introduction



Electric and Magnetic Field Fluctuations are Underdiagnosed in Tokamaks

- \tilde{E} measurements are integral to turbulent plasma physics because they provide information regarding:
 - $\tilde{E}_z \times \overrightarrow{B_\phi} = \tilde{v}_r$: cross-field transport
 - $\tilde{E}_r \times \overrightarrow{B_\phi} = \tilde{v}_\theta$: zonal flows, transport barrier
- Required for validation of tokamak core turbulence and transport models
- \tilde{E} can be extracted from fluctuations in the Stark manifold

Local \tilde{E} Results in Fluctuations in the Stark Manifold

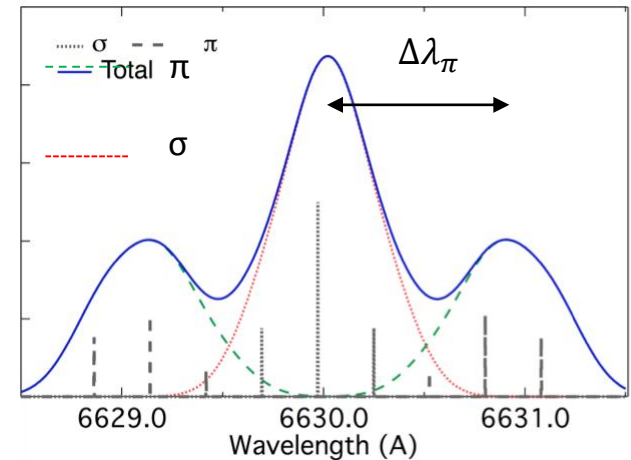
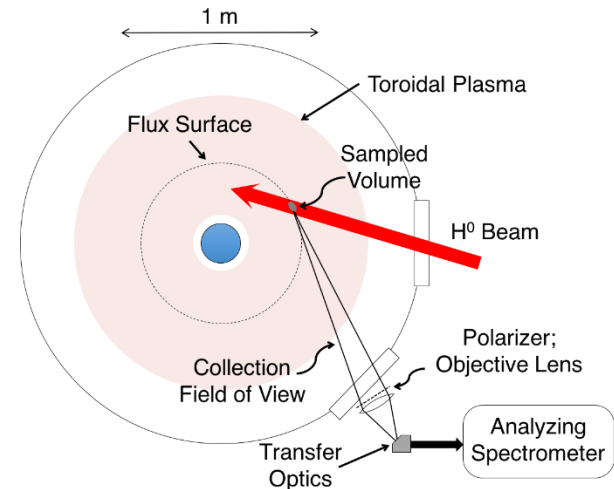
- The measured field is:

$$\mathbf{E}_{\text{tot}} = \mathbf{E}_{\text{plasma}} + \mathbf{v}_{\text{beam}} \times \mathbf{B}$$

- For 80 keV beam, $B_T = 0.3\text{T}$
- $E_{v \times B} \approx 1\text{ MV/m}$

- Two measurement methods:

- $\tilde{E}_z \propto \Delta\tilde{\lambda}_\pi$: measurement of separation of π lines
- $\alpha\tilde{E}_r \propto \frac{\pi}{\sigma}$: line intensity ratio



Modeled MSE spectrum

1 H. A. Bethe & E. E. Salpeter. *Quantum Mechanics of One- and Two-Electron Atoms*. New York: Dover Publications, Inc., 1957.

2 H. Y-H. Yuh, PhD Thesis, MIT (1995).

\tilde{E} and \tilde{B} Measurement Validation Requires a High Performance DNB

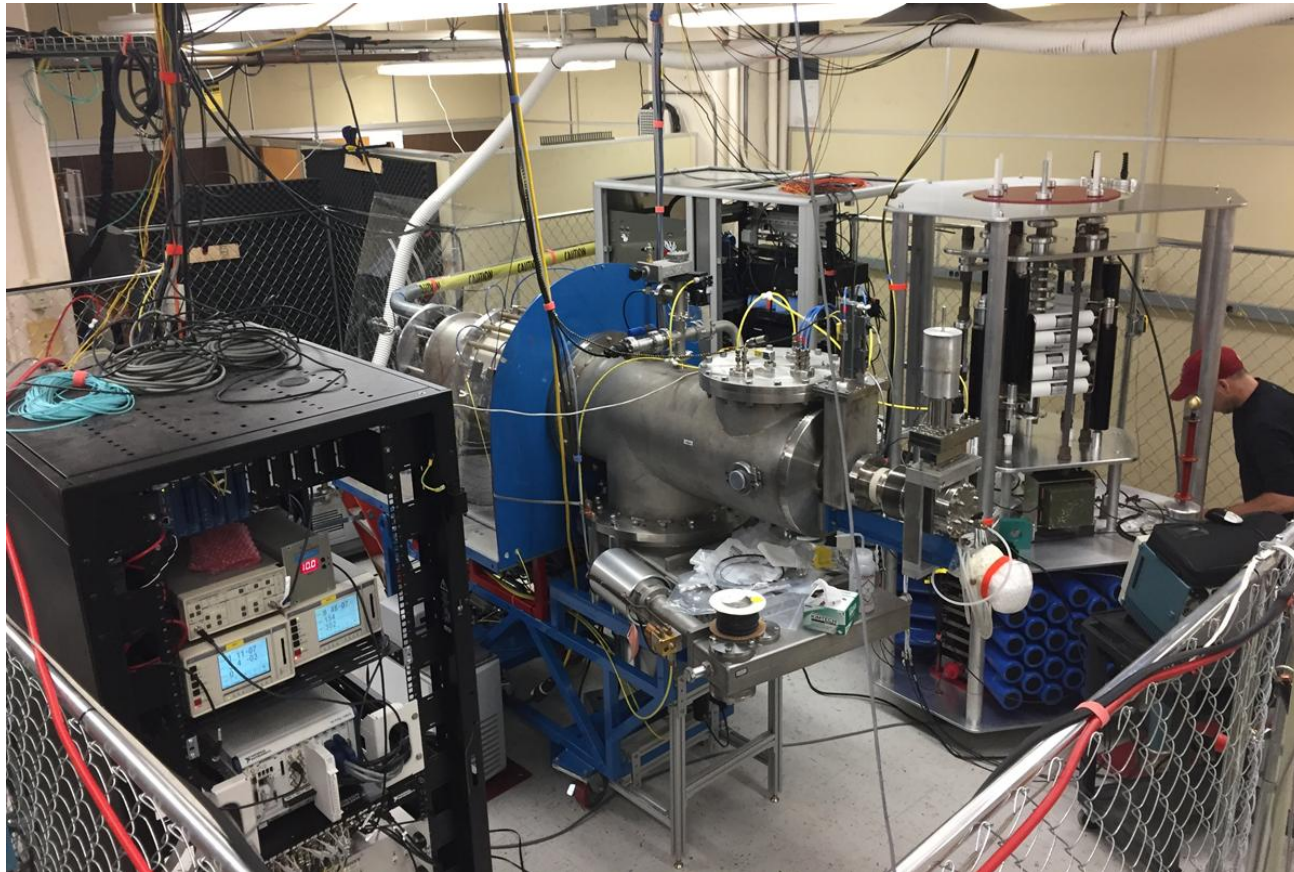
- Diagnostic neutral beam requirements:
 - Low divergence, Low $T_{i\perp}$: limit peak broadening
 - High beam fraction at full energy
 - 80 kV: High energy for spectral splitting
- Low ripple beam power supply
 - A novel three-phase resonant power supply
 - Well defined frequency components
- A novel high-speed, high-throughput spectrometer measures local \tilde{E} up to 250 kHz
 - $U \cong 0.1 \text{ cm}^2\text{-ster}$
 - Spectral resolution $\cong 0.25 \text{ \AA}$
 - See poster by M.G. Burke

Diagnostic Beam



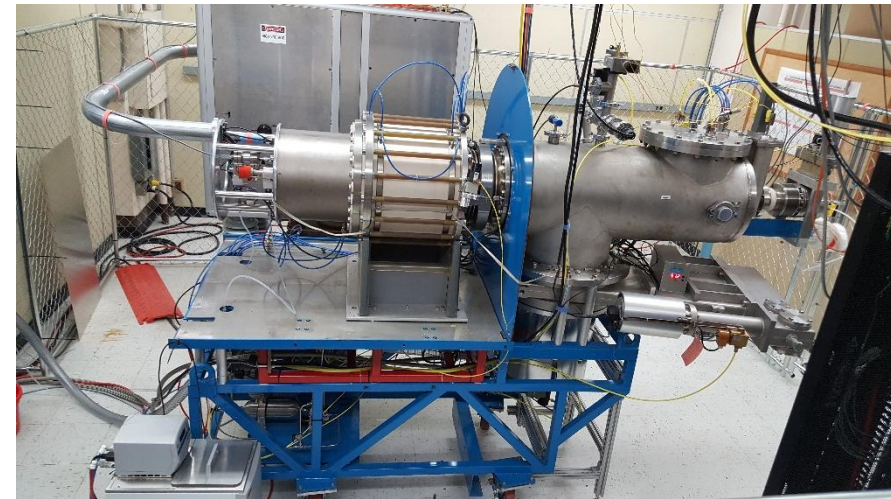
High Performance Beam Eases Field Fluctuation Measurements

- Beam produced by Culham for PPPL meets beam requirements
- Initial deployment will be on Pegasus



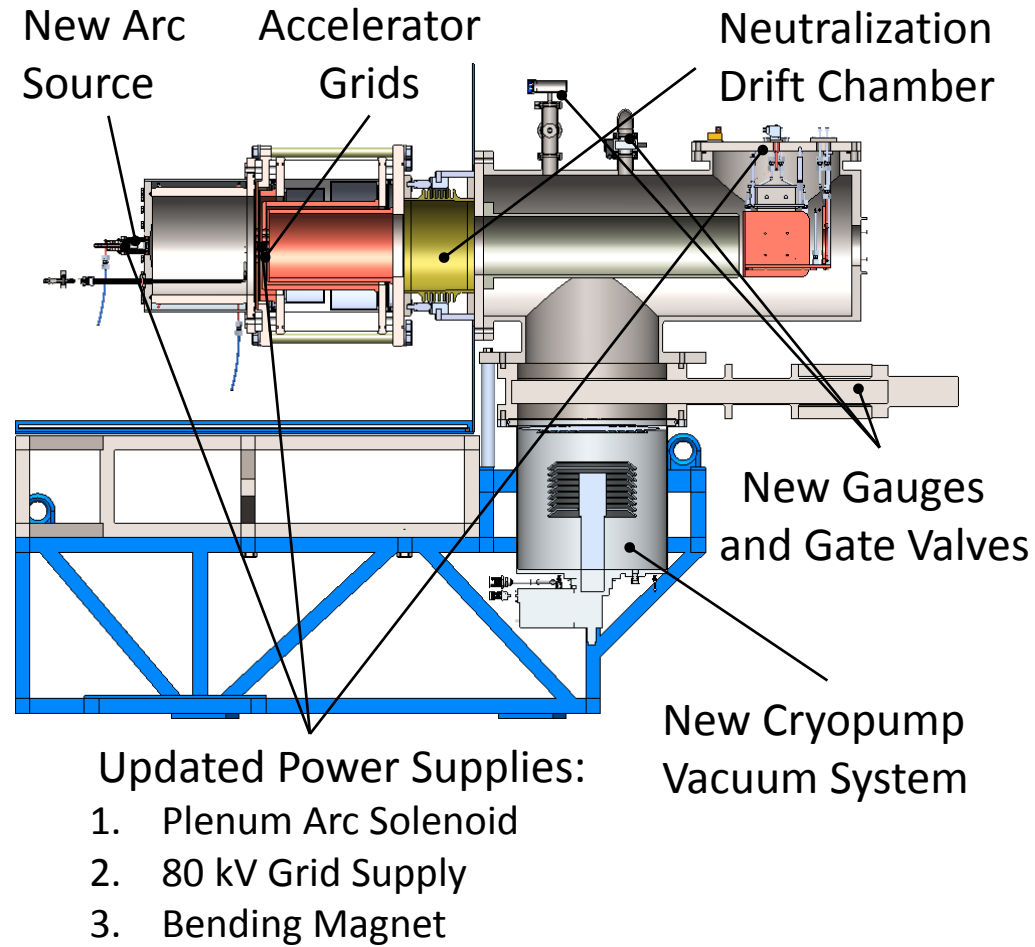
Diagnostic Requires High Energy, Low Divergence Beam

- Using DNB on loan from PPPL
 - H^0
 - Extracted Ion Current: 2-3 A
 - Full-energy J at focus: 3-6 mA/cm²
 - Diameter \sim 9cm
 - Pulse Length \sim 100ms
- Favorable features
 - Low divergence: $\leq 0.47^\circ$
 - Mitigates divergence line broadening
 - High $E_b \sim 60 - 80$ keV
 - Maximizes MSE broadening
 - 90-95% ionization at full beam energy
 - New plasma arc source
 - Optimize signal at full energy component



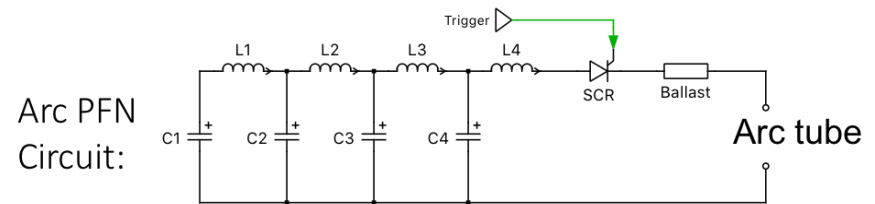
DNB Significantly Refurbished

- New Active Arc Source
 - High full energy species fraction
- Vacuum System
 - All new seals and pump
- New Power Systems
 - Low ripple, 80kV power supply
 - Arc source power supply
- New Control Systems
 - NI FPGA and DAQ controlled with LabView

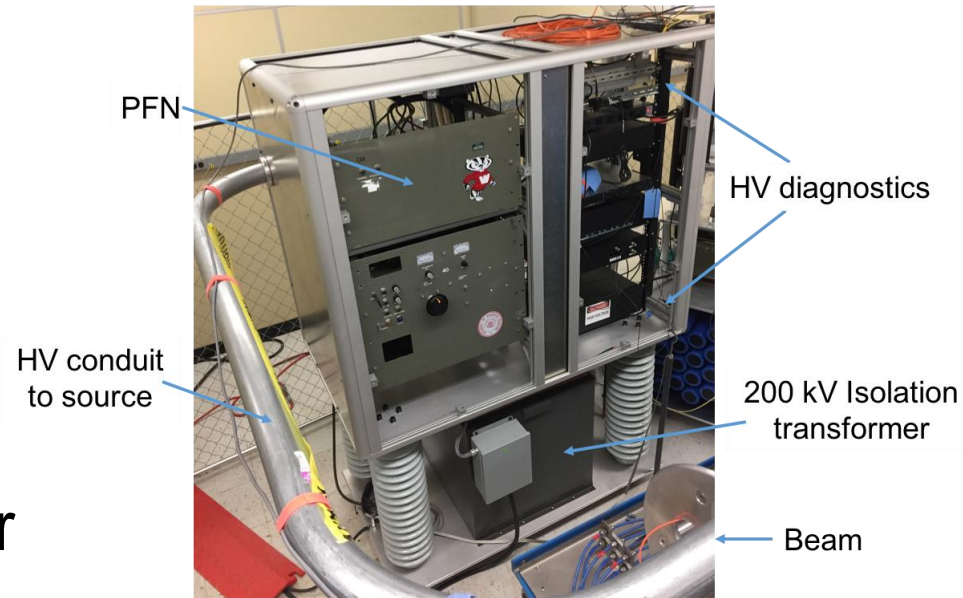


High Voltage Diagnostic Rack Commissioned

- Arc power supply
 - Pulse Forming Network (PFN)
- Sparker circuit
 - Tungsten electrode initiates breakdown at 2.5 kV
- Guide Field Power supply
- Gas valve power supplies
- HV diagnostics
 - Applied arc voltage and current
 - Langmuir probe measurements
- 200 kV Isolation transformer
- High voltage tests successful
 - 100 kV standoff



Arc PFN & High voltage Isolation Rack



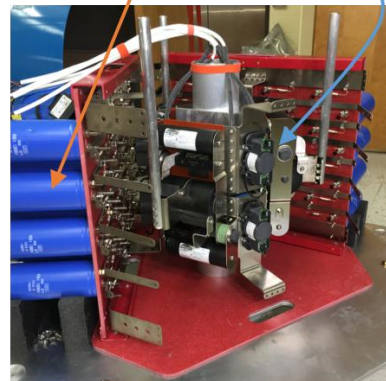
Novel Power Supply



80kV / 400kW Resonant Converter Implemented with IGBT Switches

- 35 kHz Base Switching Frequency
- 3 single phase transformers
- Fast Rise/Fall time ($< 200\mu\text{sec}$)
- Low filter energy (1J)
- Low voltage ripple ($\pm 0.00025\%$)
- Low energy per cycle (2J)
- Low primary stored energy (120kJ)
- Gain is load dependent
- Excellent fault behavior
- FPGA Control
 - 40 MHz Base Frequency
 - Digital Control

3-phase resonant bridge
& stored energy



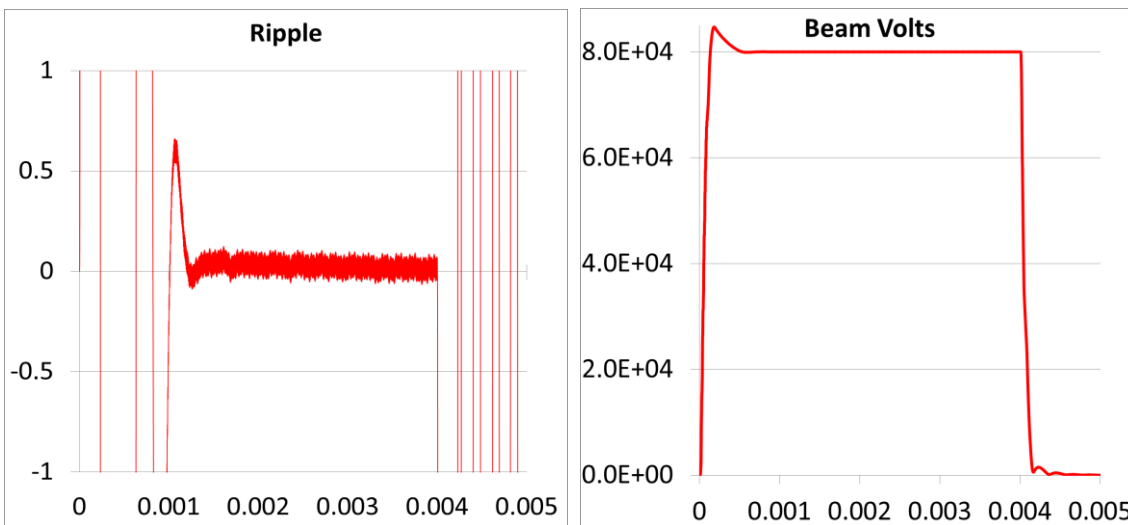
Assembled HV
Power Supply



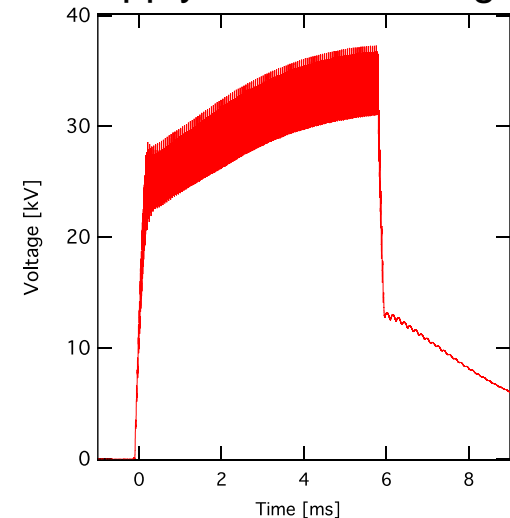
Low Ripple, 80keV High Voltage Power Supply Designed and Fabricated

- New power system required for diagnostic development
- High energy, flat voltage power supply
- Resonant converter topology for low voltage ripple

Simulated Performance with PLECS



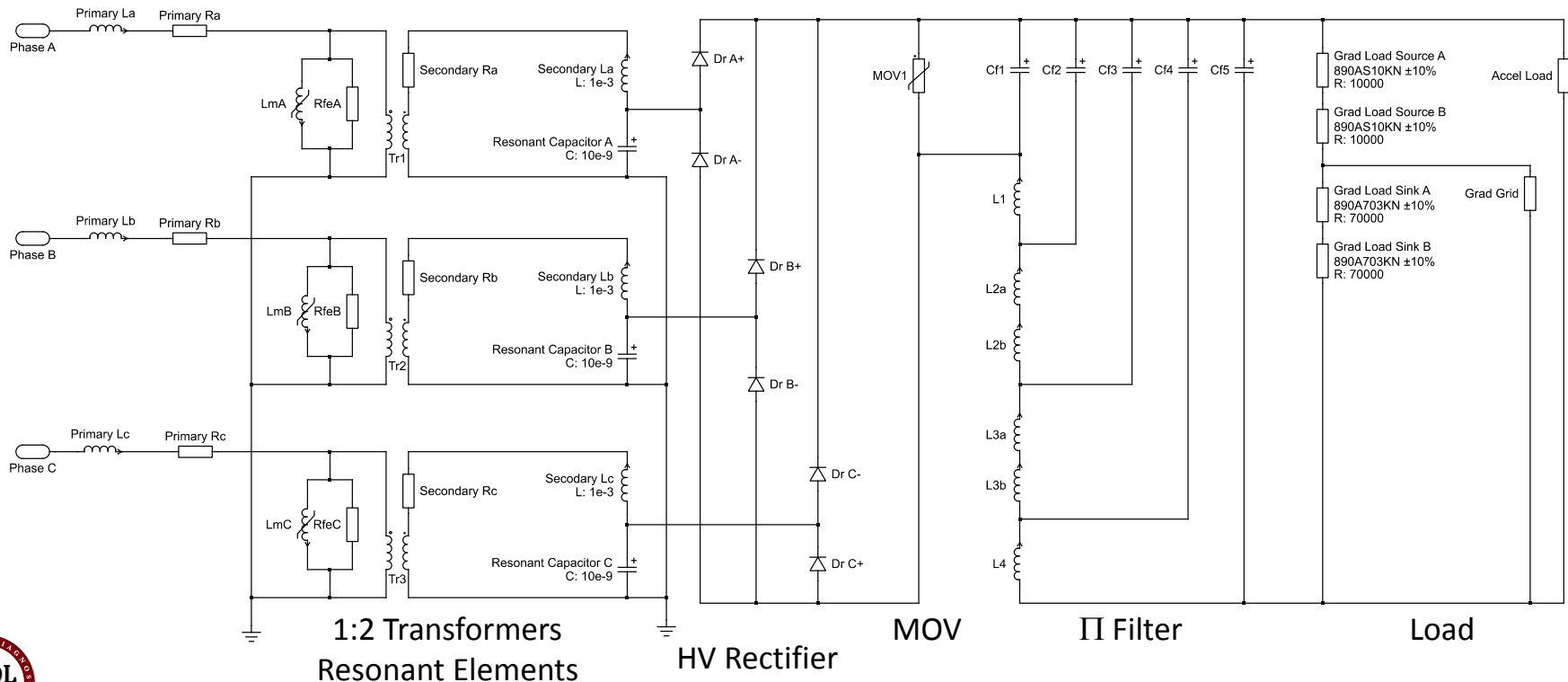
Initial Certification of Power
Supply without filtering



> 20x gain achievable in HV Section

• Resonant Converter High Voltage Section

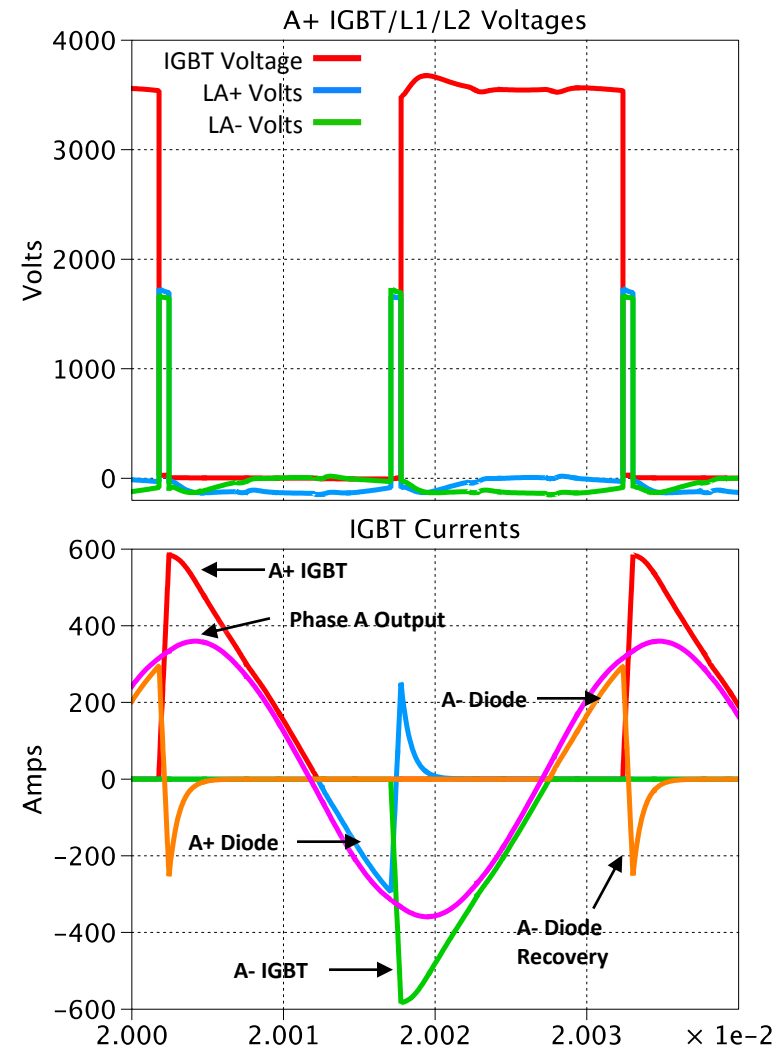
- 80kV at 5A with 1J of 80kV filter energy
- Transformer leakage inductance ($L_a/L_b/L_c$) utilized for resonant circuit
- Very fast ramp times $< 200\mu\text{s}$ to 80kV and no crowbar
- Very low ripple $\pm 0.2\text{V}$ or $\pm 0.00025\%$



Zero Voltage/Zero Current Switching Provides Minimal System Losses

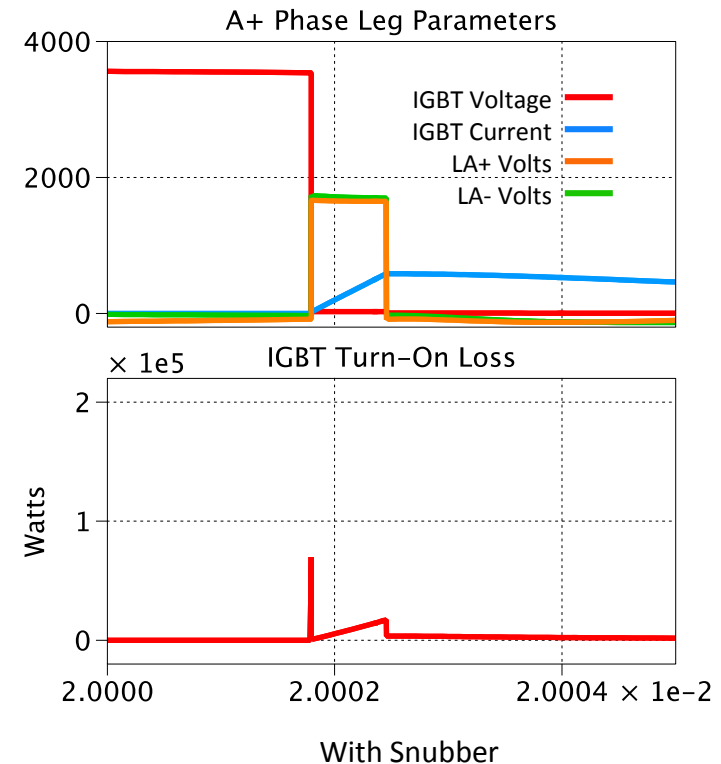
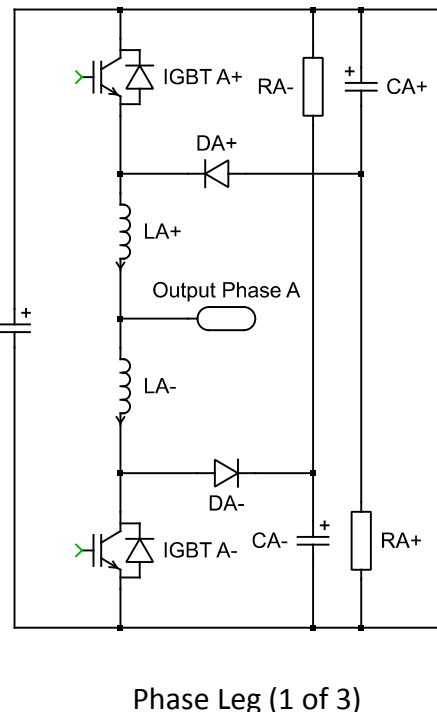
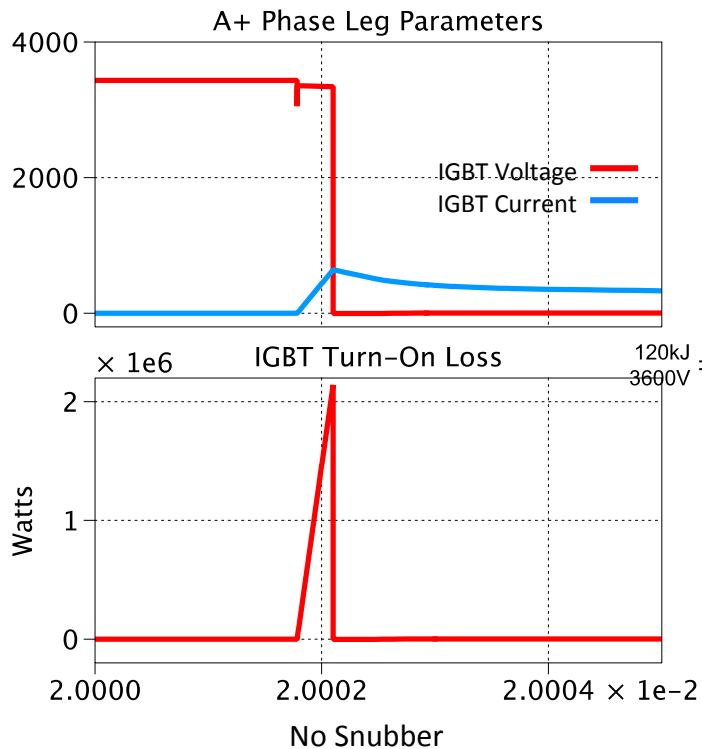
- What is ZVC/ZCS

- Passive commutation
- IGBT turn-off losses are zero
- Diode commutation at zero voltage (with snubber)
- Lower system losses allows higher frequency operation
- Higher frequency allows for higher power density (lower energy per cycle)
- What's not to like?
 - Lowest loss only at resonance
 - Turn-On losses can still be significant
 - Impedance imbalances cause trouble
 - Control difficult because of dynamic gain



Multi-pole Bridge Snubber Minimizes Switching Losses

- Clamps device for $\sim 400\text{nsec}$
- Allows turn-on of IGBT at zero voltage
- Loss reduction enables access to higher switching frequencies

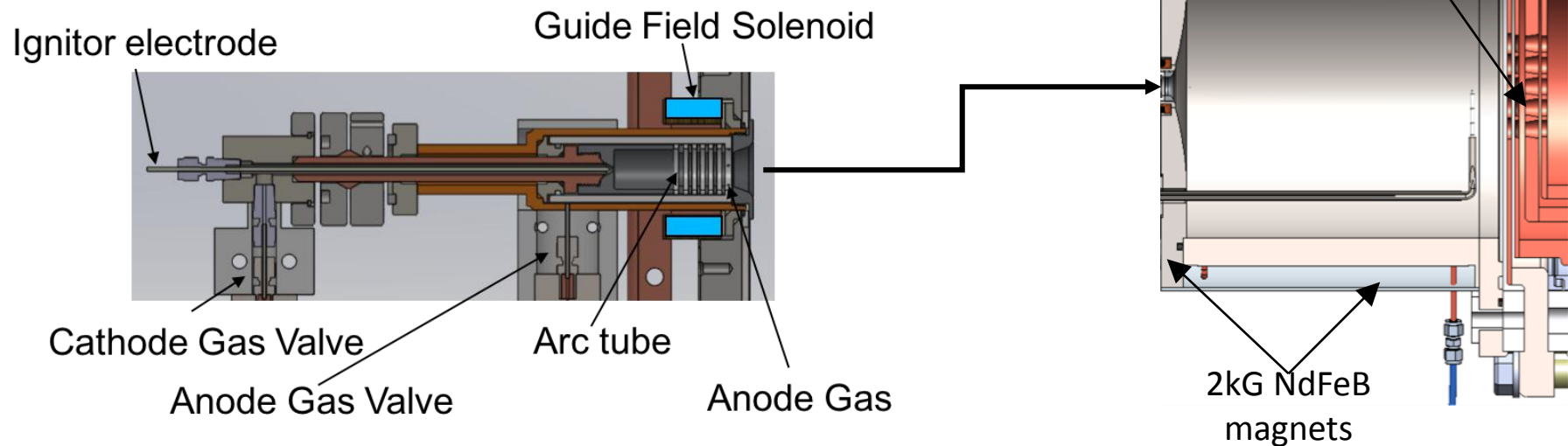


Source Plasma Characterization



New High Density Arc Plasma Deployed to Provide Optimal Species Mix

- Hot filament source replaced with washer stack arc source
 - Provides high ionization fraction (80-90%)¹⁻³
 - Molybdenum washers separated by boron nitride washers
- Plasma expands into a bucket with multipole cusp fields



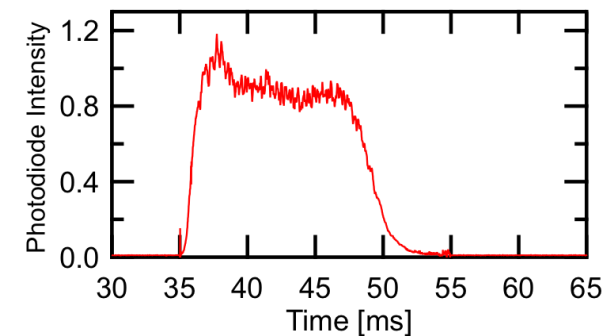
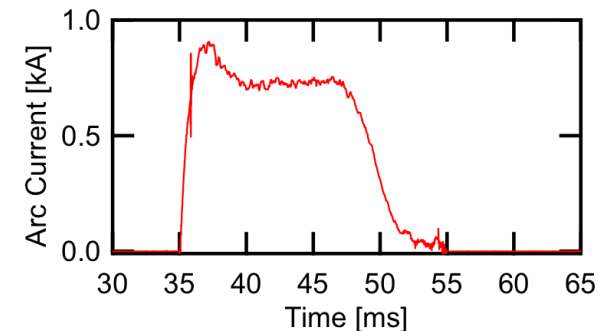
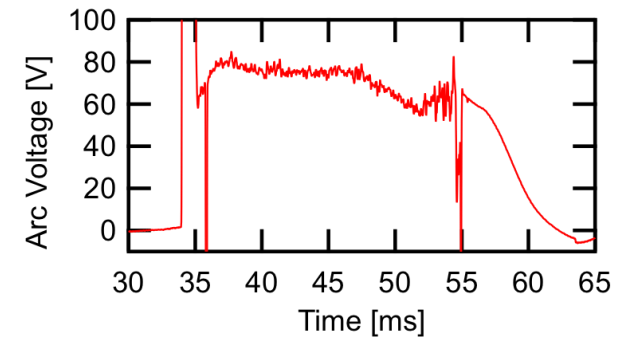
¹ Deichuli et al, *Rev. Sci. Instrum.* **79**, 02C106 (2008)

² Abdrashitov, et al, *Rev. Sci. Instrum.* **72**, 594 (2001)

³ Korepanov, et al, *Rev. Sci. Instrum.* **75**, 1829 (2004)

Shot Parameters for Typical Arc Discharge

- Arc Discharge
 - Breakdown initiated by 2.5 kV sparker
 - PFN discharges into the arc
 - ~10 ms pulse length
 - Potential to extend with new power supply
- Shot Parameters:
 - 80 V of arc voltage
 - ~800 A arc current
 - Plasma light intensity mimics arc current



Ion Source Needs to Match Grid Perveance Requirements

- Beam Extraction Requirements

- Extracted Current at 80kV: 2.5 A
- Grid Extraction area: $19 \times 1.52 \text{ cm}^2$

$$\rightarrow j_{\text{ext}} \approx 87 \text{ mA/cm}^2$$

- Near the grids: $j_{\text{plasma}} = n_e e v_B \rightarrow j_{\text{ext}} = I_{\text{ext}}/A_{\text{ext}}$

- Where $v_B = \sqrt{T_e / m_i}$

- Source Requirements to meet j_{ext} at the grids:

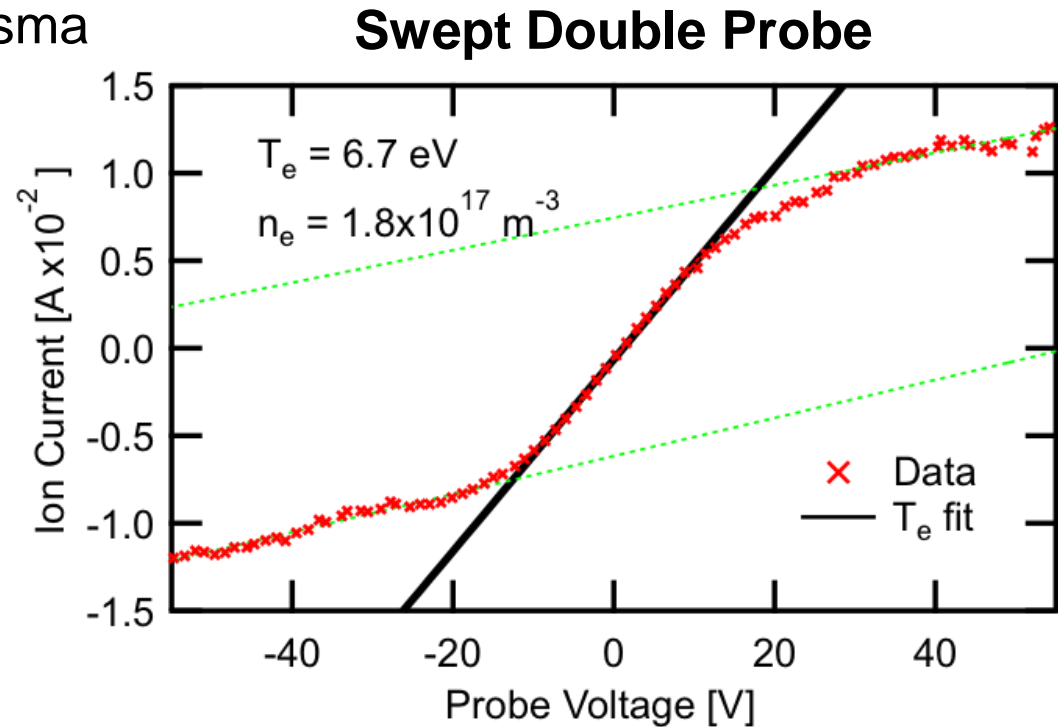
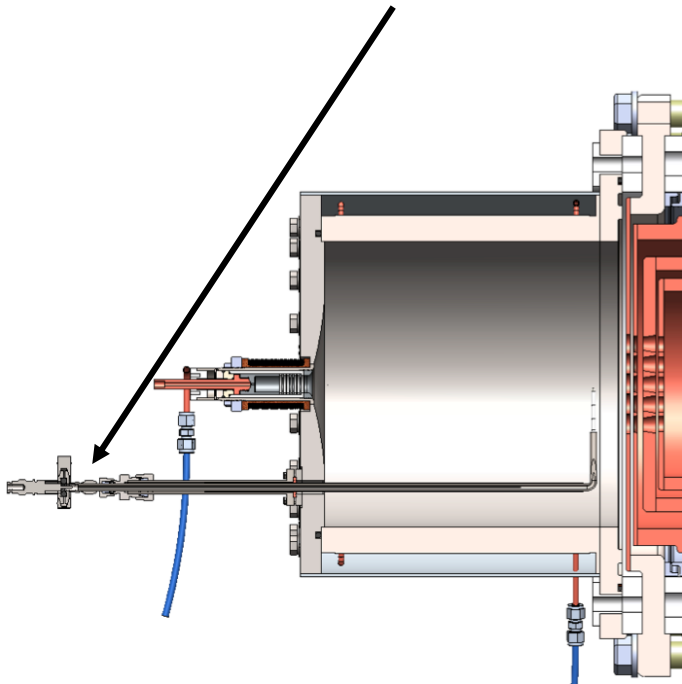
- $T_e \gtrsim 4 \text{ eV}$
- $n_e \sim 2 \times 10^{17} \text{ m}^{-3}$

* N. Hershkowitz. "How Langmuir Probes Work."
Plasma Diagnostics, 113-183. Academic Press, 1989.



Desired Operational Space Achieved

- A retractable and rotatable probe was designed for complete characterization of source plasma



Johnson and Malter, Phys. Rev.. **80**, 58 (1950)

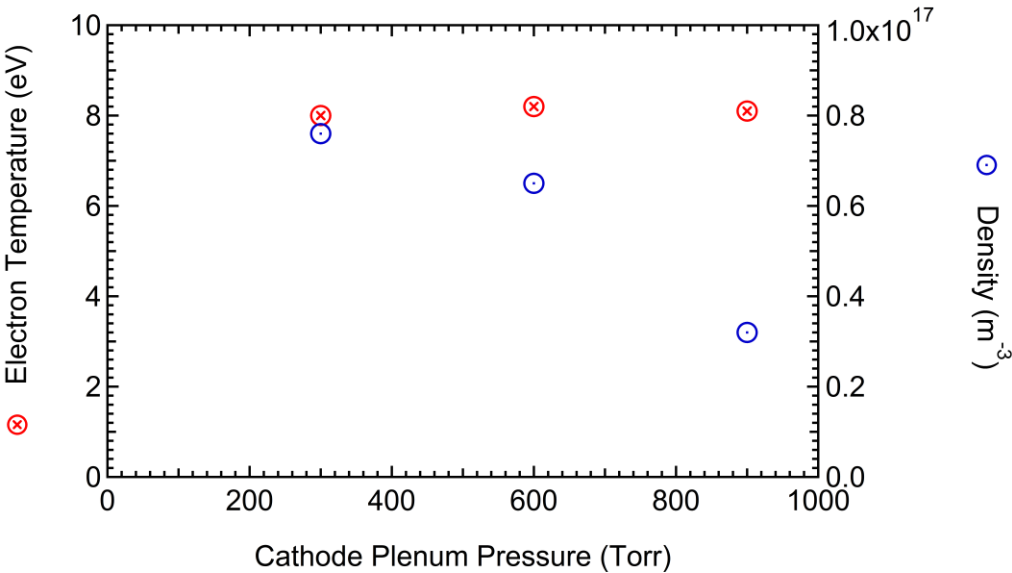
Arc Performance Optimization



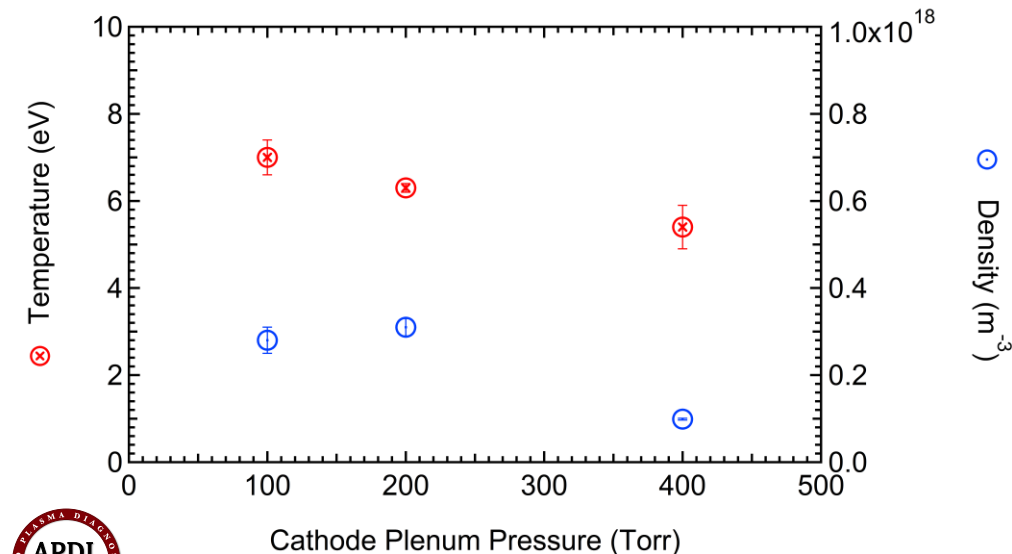
Stable Arc Discharge Required

- \widetilde{n}_e at the extraction plane may impact beam divergence
- Demonstrated ability to vary density
 - Match beam perveance
- Recent work has improved arc discharge stability
 - Additional hydrogen fueling at anode
 - Magnetic guide field strength

Cathode Gas Flow Rate Varies Plasma Source Parameters

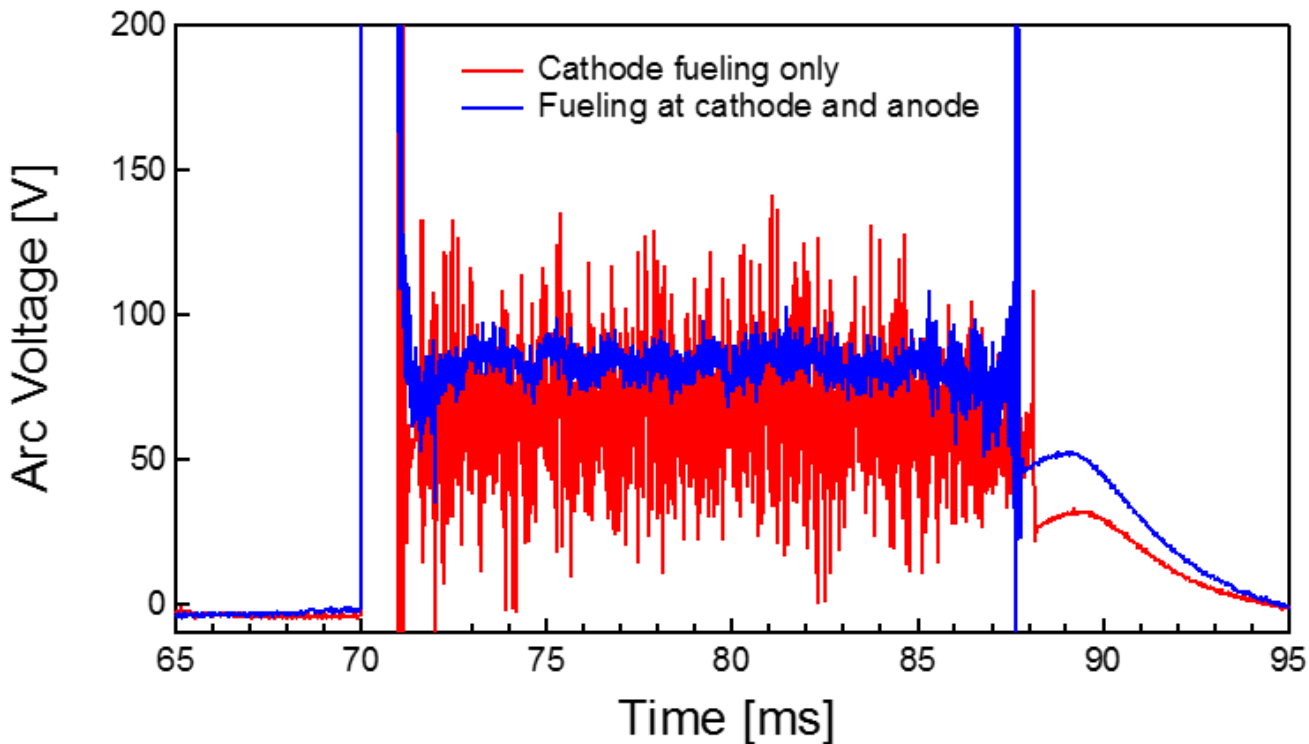


Decreased cathode fueling
increases plasma density
while maintaining T_e



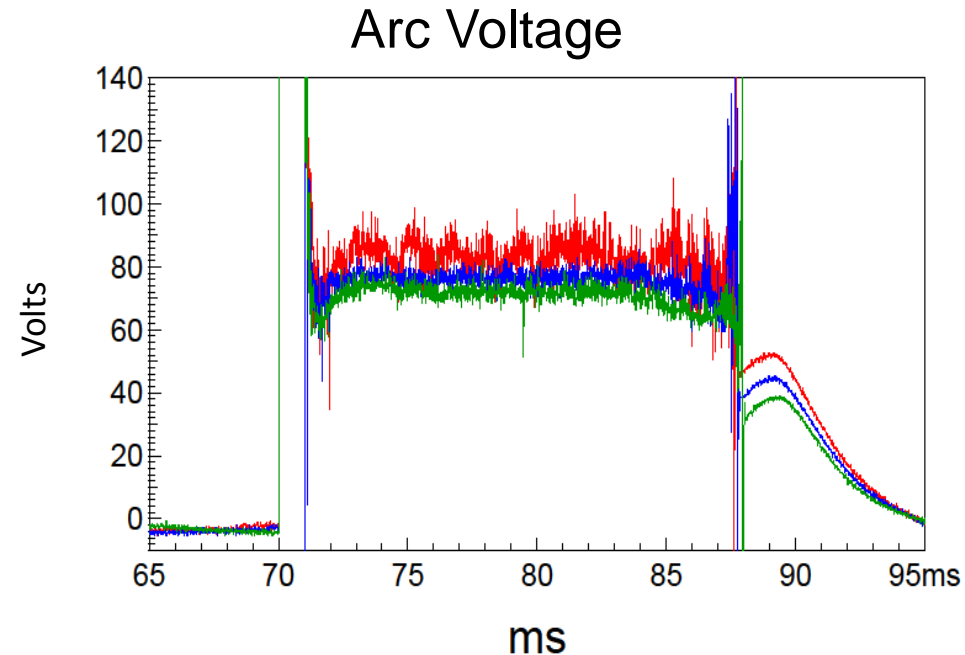
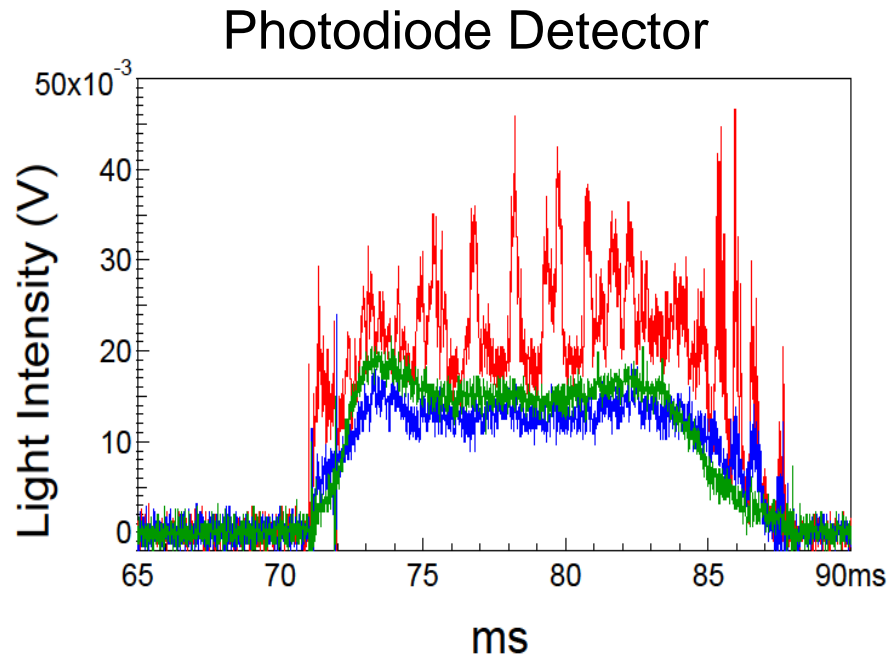
Anode Fueling Integral to Arc Stability

Voltage fluctuations in the arc reduced through gas feedthrough at the anode



Arc Stability Modified by Strong Guide Field

- High guide field induces arc instability



— 1.2kGauss
— 0.6kGauss
— 0.24kGauss

Validation of Electric Field Fluctuation Diagnostic Enabled by Optimized DNB

- A low-divergence, high energy diagnostic neutral beam (from PPPL) completely rebuilt
- New washer-stabilized plasma arc source gives required n_e at $T_e \sim 7$ eV
- Source plasma stabilized by anode fueling
- A novel three phase resonant converter power supply has been designed and built for low ripple, constant voltage output
- Commissioning of HV PS to be followed by initial DNB operation

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Future Works

- Arc power and diagnostics rack tested successfully to 100kV
- High Voltage Power Supply testing in progress
 - Initial tests have achieved 36 kV
 - Test to 80 kV
 - Add filter network to reduce ripple
- Conditioning of accelerator grids to commence in short order
- Integration of new 80kV power supply after grid conditioning
- After conditioning, ion species mix and beam divergence measurements will determine arc discharge parameters